



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 4569

SERIAL NUMBER 10/539,223	FILING OR 371(c) DATE 02/01/2006 RULE	CLASS 356	GROUP ART UNIT 2877	ATTORNEY DOCKET NO. AB-1448 US
APPLICANTS Jae-Gab Lee, Seoul, KOREA, REPUBLIC OF; Chang-Oh Jeong, Suwon-city, KOREA, REPUBLIC OF; Myung-Mo Sung, Goyang-city, KOREA, REPUBLIC OF; Hee-Jung Yang, Namyangju-city, KOREA, REPUBLIC OF; Beom-Seok Cho, Seoul, KOREA, REPUBLIC OF;				
** CONTINUING DATA ***** This application is a 371 of PCT/KR03/00599 03/26/2003 <i>SWC</i>				
** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 10-2003-0000757 01/07/2003 <i>SWC</i>				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>John W. Crane</i> <i>SWC</i> Examiner's Signature Initials		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 38	TOTAL CLAIMS 13
			INDEPENDENT CLAIMS 5	
ADDRESS 32605				
TITLE Thin film transistor substrate and method for forming metal wire thereof				
FILING FEE RECEIVED 1790	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	